Attorney Docket SEL 163

In Re	Application of)		The state of the s
Murak	ami et al.)		9
Serial No.: 09/516,082)	I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: the Assistant Commissioner for Patents, Washington, D.C. 20231 on (Date of Deposit)	
Filed: March 1, 2000)		
For:	Semiconductor Device Comprising A Thin Film Transistor Comprising A Semiconductor Thin Film And Method of Manufacturing The Same (as amended)		Man I Casim Name of applicant, assignee, of have a Casim Signature	r Registered Rep.
Art Unit: 2815)		HNOLOGY I
Examiner: E. Lee)		7 2003 CENTER
Commissioner for Patents Washington, D.C. 20231		• •		R 2800

AMENDMENT C (AFTER FINAL)

Sir:

In response to the Final Rejection of December 16, 2002, please amend the above-identified application as follows:

Please substitute the following title for the title: 00000012 501039 09516082

01 FC:1201

588 Sensi conductor Device Comprising A Thin Film Transistor Comprising A Semiconductor Thin

Film And Method of Manufacturing The Same